

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXPRESS MAIL NO. EV327880615US

Appl No. : N/A Confirmation No.  
Applicant : Naoya Takeuchi  
Filed : February 17, 2004  
Title : PATTERN INSPECTION METHOD AND APPARATUS

TC/A.U. : N/A  
Examiner : N/A

Docket No. : 51971/DBP/A400  
Customer No. : 23363

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Post Office Box 7068  
Pasadena, CA 91109-7068  
February 17, 2004

Commissioner:

Prior to examination, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.